

Device Architecture for Next Generation CdTe PV



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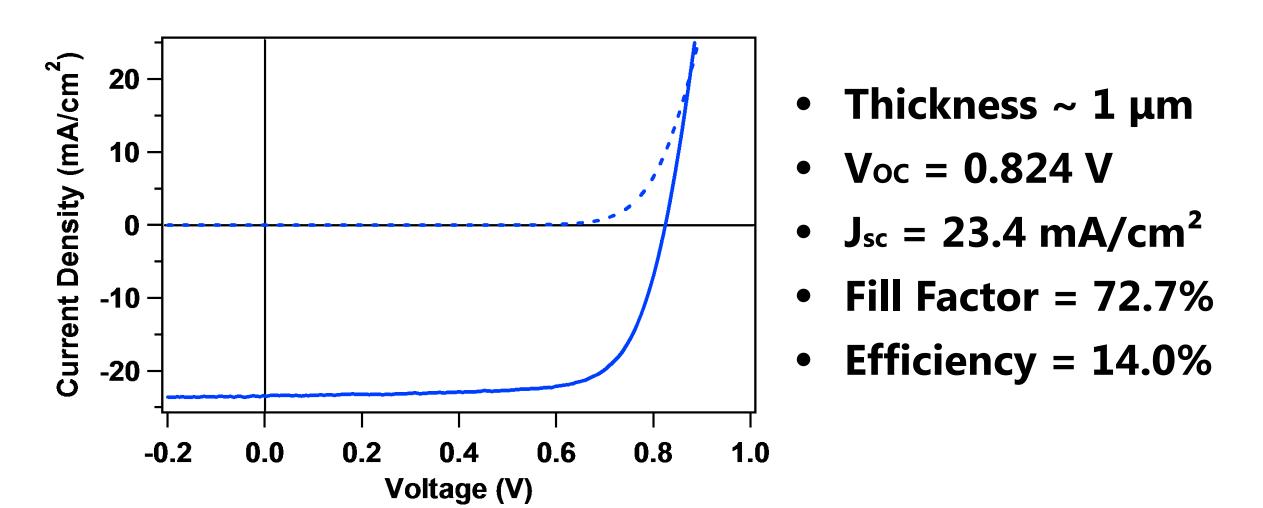
Project Goal

Achieve higher open-circuit voltages for CdTe cells without loss of current or fill-factor. The target is a 150 mV voltage increase that can be replicated in commercial modules.

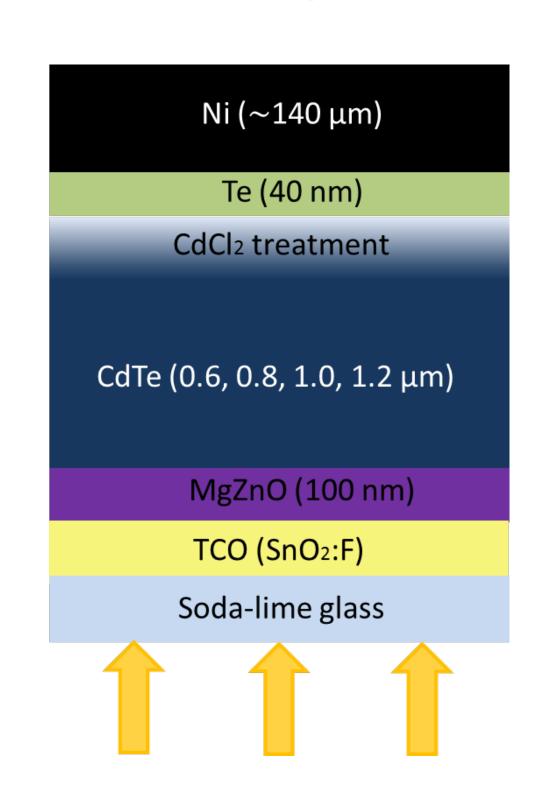
Key Accomplishments

- Good quality cells fabricated with systematic variation in CdTe thickness: 0.6, 0.8, 1.0, 1.2 μm
- Optimization of CdCl₂ passivation and Cu doping achieved
- Efficiency of cells with ~one-micron CdTe absorbers reached 14% with Voc of 824 mV
- Cells show excellent crystal structure and continuous MgZnO and Te layers
- TRPL suggests low recombination at MgZnO interface, higher at Te interface

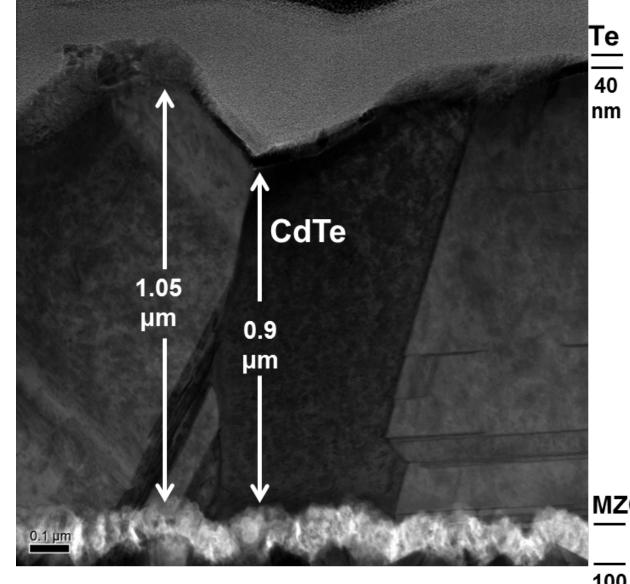
Record Thin-Absorber Device



Device Structure



Contact



Cross-sectional SEM shows

- Large-grain CdTe
- Continuous MgZnO layers

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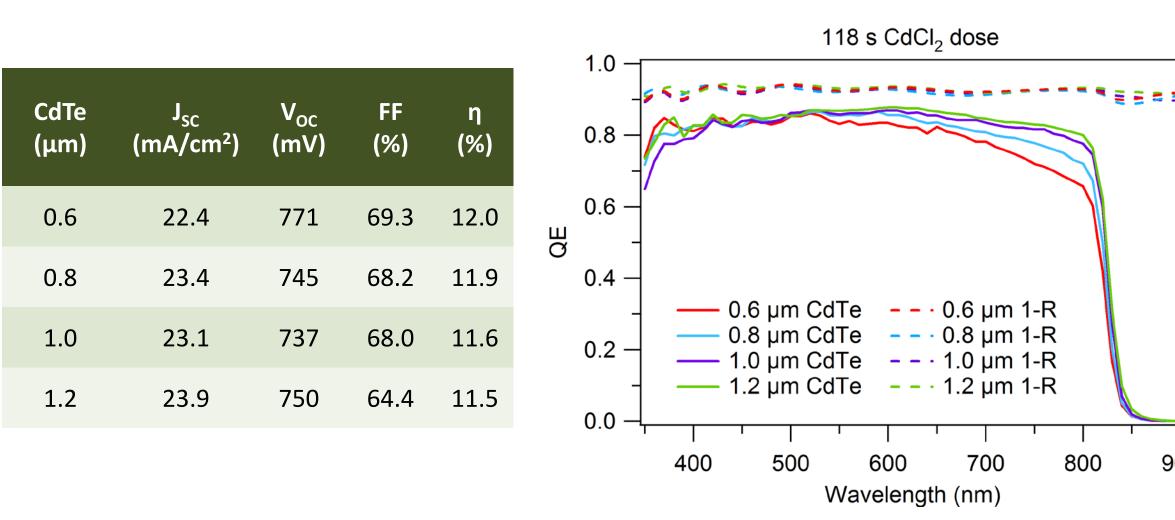
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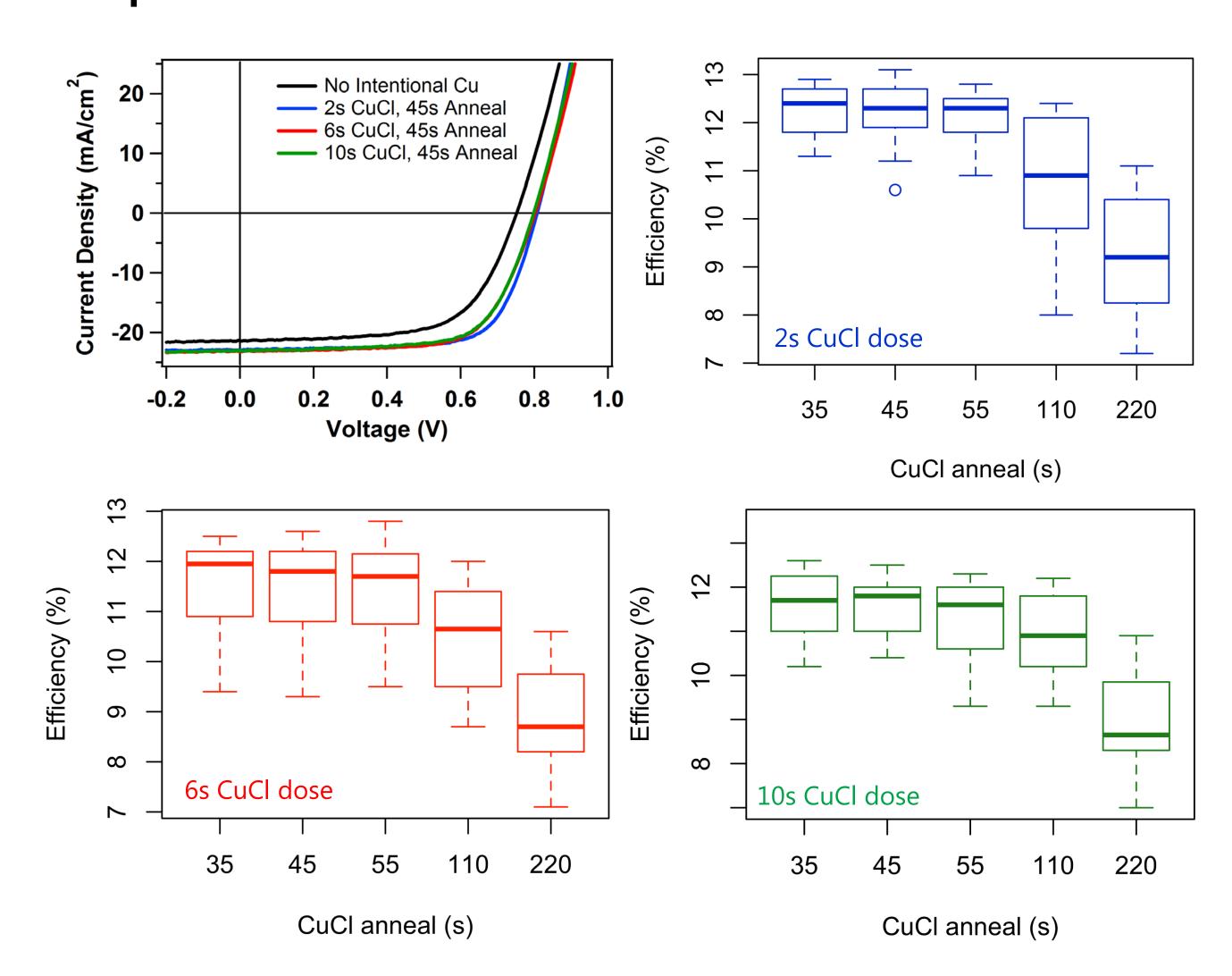
Device Characterization

1. Optimization

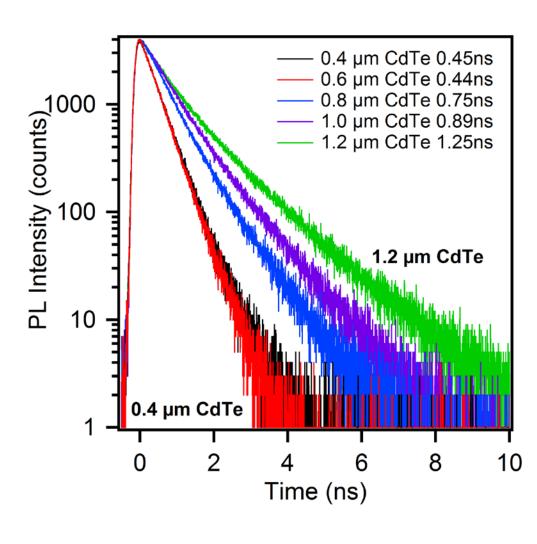
- J-V parameters vs. CdCl₂ dose shows optimal dose time ≈120 seconds, independent of absorber thickness
- QE reveals thinner absorbers suffer more current loss at longer wavelengths due to incomplete absorption



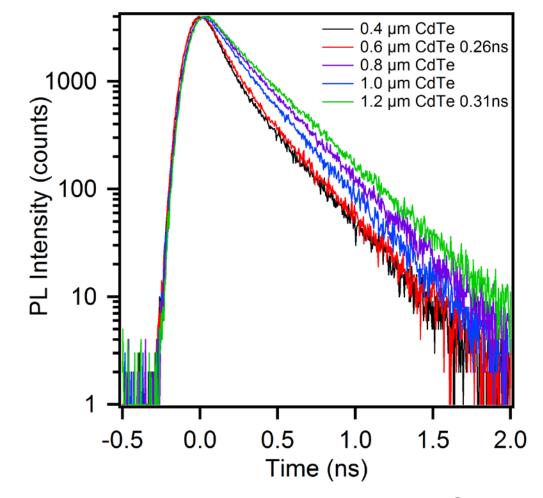
Efficiency as a function of CuCl doping and anneal time shows optimization of 2 second dose with ~50 second anneal



2. Time Resolved Photoluminescence (TRPL)



Single photon TRPL: lifetime increases with **CdTe thickness**

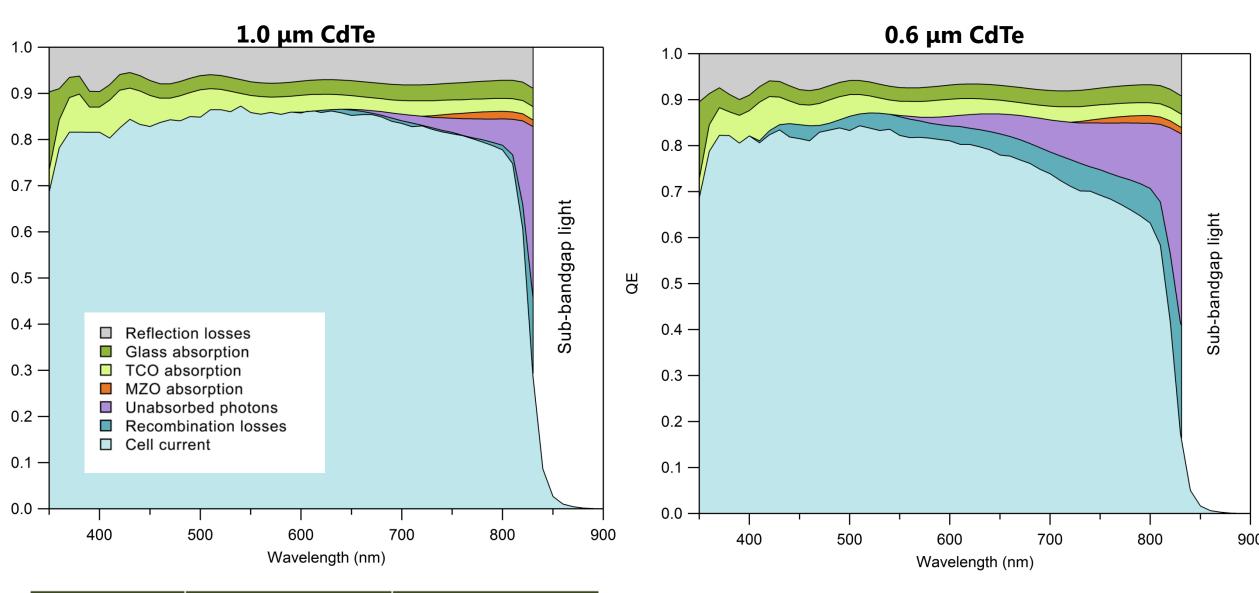


 Two photon TRPL (from Te side): lack of thickness dependence suggests back interface recombination

dominates

3. Loss Analysis

Current



Decreased Voc

Larger A-factor (=1.9)

Series resistance

Shunt resistance

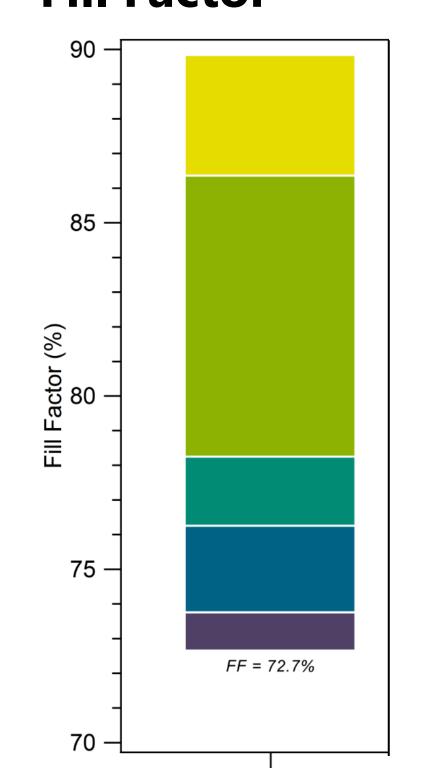
Other

Mechanism	1.0 μm Device Current Density (mA/cm²)	0.6 μm Device Current Density (mA/cm²)
Cell current	24.0	21.9
Reflection	2.1	2.1
Glass absorption	1.0	1.0
TCO absorption	1.1	1.1
MZO absorption	0.1	0.1
Unabsorbed photons	0.6	1.6
Recombination losses	0.1	1.2

QE losses show reflection is largest source of loss

Losses due to unabsorbed photons and recombination increases for thinner absorber

Fill Factor

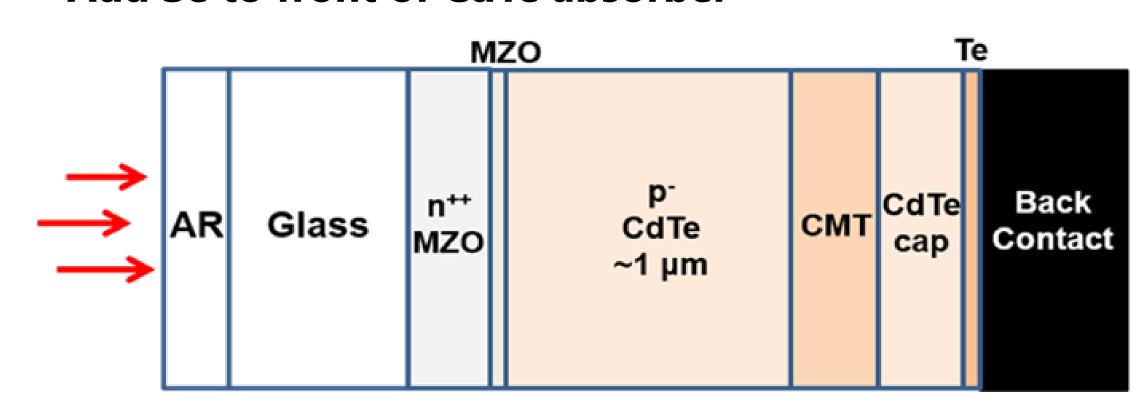


 Fill factor losses show a large A factor is largest source of loss followed by decreased Voc

Future of Project

1.3 µm CdTe

- Incorporation of electron reflector at back of device with addition of CdMgTe and CdTe cap layers
- Add Se to front of CdTe absorber



Acknowledgments

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